

In re Patent Application of

TAKENAKA

Atty. Ref.: 900-473

Serial No. To be assigned

Group: Unknown

Filed: September 5, 2003

Examiner: Unknown

For: MANUFACTURING METHOD FOR SEMICONDUCTOR SUBSTRATE,
SEMICONDUCTOR SUBSTRATE AND SEMICONDUCTOR DEVICE

* * * * *

September 5, 2003

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT

As suggested by 37 C.F.R. 1.97, the undersigned attorney brings to the attention of the Patent and Trademark Office the references listed on the attached form PTO-1449, a copy of each of which is enclosed. This is not to be construed as a representation that a search has been made or that no better prior art exists, or that a reference is relevant merely because cited.

The Examiner is requested to initial the attached form PTO-1449 and to return a copy of the initialed document to the undersigned as an indication that the attached references have been considered and made of record.

Respectfully submitted,

NIXON & VANDERHYE P.C.

By:



H. Warren Burnam, Jr.

Reg. No. 29,366

HWB:dbd

1100 North Glebe Road, 8th Floor

Arlington, VA 22201-4714

Telephone: (703) 816-4000

Facsimile: (703) 816-4100

**INFORMATION DISCLOSURE
CITATION**

ATTY. DOCKET NO.

SERIAL NO.

900-473

To be assigned

APPLICANT

TAKENAKA

(Use several sheets if necessary)

FILING DATE

GROUP

September 5, 2003

Unknown

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

DOCUMENT	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO

OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)

	H. Trinkaus et al., "Strain relaxation mechanism for hydrogen-implanted Si _{1-x} Ge _x /Si(100) heterostructures", APPLIED PHYSICS LETTERS, Vol. 76, No 24, 12 June 2000, pp. 3552-3554
	D. M. Follstaedt et al., "Cavity-dislocation interactions in Si-Ge and implications for heterostructure relaxation", APPLIED PHYSICS LETTERS, 69 (14), 30 September 1996, pp. 2059-2061

*Examiner

Date Considered

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application.